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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Olivier RAYSSAC et al.

Confirmation No.: 5939

Application No.: 10/777,721

Group Art Unit: 2811

Filing Date: February 11, 2004

Examiner:

For: SEMICONDUCTOR STRUCTURE AND
METHOD OF MAKING SAME

Attorney Docket No.: 4717-10700

SECOND INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to applicants' duty of disclosure under 37 C.F.R. § 1.56, enclosed is Form PTO-1449 listing two (2) references for the Examiner's review and consideration. Also enclosed is a copy of the International search report from a corresponding foreign application on which the references were cited. A copy of non-patent document C1 is provided herewith. A copy of U.S. patent document A1 will be provided if the Examiner so requests.

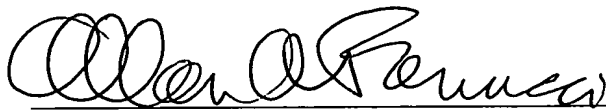
It is respectfully requested that the references be made of record in this application by the Examiner's completion and return of the attached Form PTO-1449.

This Second Information Disclosure Statement ("IDS") is filed under 37 C.F.R. § 1.97(c). Applicants hereby certify under 37 C.F.R. § 1.97(e)(1) that the references contained in this IDS were first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this IDS. Accordingly, no fee is believed to be due. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

Date

10/14/04


Allan A. Fanucci, Reg. No. 30,256

WINSTON & STRAWN LLP
Customer No. 28765

212-294-3311

